

2/7/00

A

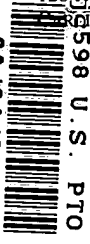
T. A. LOBER PATENT SERVICES

128 ROBBINS DRIVE
ROSLINDALE, MASSACHUSETTS 01741

**PATENT REPRESENTATION BEFORE THE
U.S. PATENT & TRADEMARK OFFICE**

OFFICE 978.369.2181
FACSIMILE 978.369.7101
INTERNET lober@lober-patent.com

02/04/00



BOX PATENT APPLICATION

The Assistant Commissioner For Patents
Washington, D.C. 20231

Docket No.: MIT7941



INVENTORS: Yong-Pil Han and Herbert H. Sawin

FOR: HF Vapor Phase Wafer Cleaning and Oxide Etching

This new application is filed with the following papers:

- | | |
|-------------------------------------|---|
| <input checked="" type="checkbox"/> | <u>51</u> sheets of Specification |
| <input checked="" type="checkbox"/> | <u>6</u> sheets of Claims |
| <input checked="" type="checkbox"/> | <u>1</u> sheet of Abstract of the Disclosure |
| <input checked="" type="checkbox"/> | <u>15</u> sheets of Informal drawings: Figs. 1-20 |
| <input type="checkbox"/> | <u> </u> sheets of original Signed verified statement to establish small entity status under 37 CFR 1.9 and 37 CFR 1.27. |
| <input checked="" type="checkbox"/> | <u>3</u> sheets of unsigned Declaration and Authorization of Agent |

Priority Under 35 U.S.C. §§119(e)

This application claims the benefit of the below-identified U.S. Provisional Application:

APPLICATION NUMBER

60/118,937

FILING DATE

February 5, 1999

09/498303-020400

Filing Fees

For	No. Filed	No. Extra	Sm/Lg Rate	Small Ent. Fee	Large Ent. Fee
Basic Fee:	---	----	\$345/\$690		\$ 690.00
Total Claims:	<u>35</u>	- <u>20</u> = <u>15</u>	\$9/\$18		\$ 270.00
Independent					
Claims: :	<u>11</u>	- <u>03</u> = <u>8</u>	\$39/\$78		\$ 624.00
Multiple					
Dep. Claims:	YES		\$130/\$260		\$ 260.00
<u>TOTAL FILING FEE:</u>					<u>\$1844.00</u>

Please apply the filing fee of \$1844.00 to Deposit Account No. 19-2553. Please apply any credits and any additionally required fee charges beyond those indicated above to Deposit Account No. 19-2553.

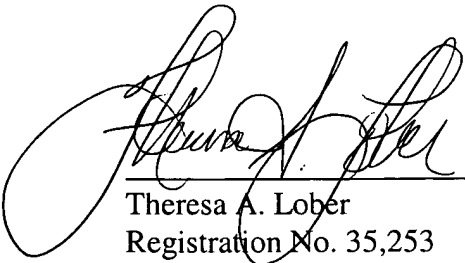
Correspondence

Theresa A. Lober
T. A. Lober Patent Services
128 Robbins Drive
Carlisle, Massachusetts 01741
Telephone: 978.369.2181
Facsimile: 978.369.7101

Kindly acknowledge receipt of the foregoing application by returning the two enclosed self-addressed and stamped postcards.

Respectfully submitted,

Date: February 4, 2000


Theresa A. Lober
Registration No. 35,253
Agent for Applicants

Docket No.: MIT7941

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

TRANSMITTED HERewith FOR FILING IS THE

NEW NONPROVISIONAL
PATENT APPLICATION

UNDER 37 C.F.R. §1.53(b)

OF

**Yong-Pil Han
and
Herbert H. Sawin**

FOR

HF VAPOR PHASE WAFER CLEANING AND OXIDE ETCHING

EXPRESS MAIL Mailing Label No.: EJ872376359US

Date of Deposit: February 4, 2000

I hereby certify that this paper and all attachments are being deposited with the United State Postal Service "Express Mail Post Office to Addressee" Service under 37 C.F.R. 1.10 on the date indicated above, and is addressed to Box Patent Application, Assistant Commissioner For Patents, Washington, D.C. 20231.

Theresa A. Lober

February 4, 2000
